

	Type	L #	Hits	Search Text	DBs
1	BRS	L1	2382	imag\$3 with interferom\$5	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
2	BRS	L8	1053	1 and (semiconductor or wafer or fabrication or alignment)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
3	BRS	L15	326	1 and (semiconductor or wafer or fabrication or alignment).ab.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
4 .	BRS	L22	114	8 and (((short or low) adj coherence) or incoherent)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
5	BRS	L29	12	15 and 22	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB

	Type	Hits	Search Text	DBs
1	IS&R	86	(356/497).CCLS.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
2	IS&R	62	(356/509).CCLS.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB
3	IS&R	144	(356/511).CCLS.	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB